

Customer No.: 31561
Application No.: 10/708,209
Docket No.: 11583-US-PA

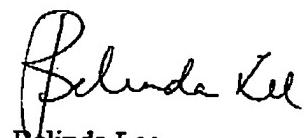
REMARKS

Applicant would like to elect Group II, claims 4-10, drawn to a thin film transistor array substrate, classified in class 257, subclass 72. Please cancel Group I, claims 1-3, drawn to a photolithography process of a thin film transistor substrate, classified in class 438, subclass 48 without waiver, prejudice or disclaimer.

If the Examiner believes that a telephone conference would expedite the examination of the above-identified patent application, the Examiner is invited to call the undersigned.

Respectfully submitted,

Date: Nov. 24, 2004



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